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**PATENT APPLICATION  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q60006

Hiromoto OHNO, et al.

Appln. No.: 09/822,211

Group Art Unit: 1743

Confirmation No.: 9864

Examiner: Monique T. COLE

Filed: April 2, 2001

For: MEASURING METHOD FOR CONCENTRATION OF HALOGEN AND FLUORINE COMPOUND,  
MEASURING EQUIPMENT THEREOF AND MANUFACTURING METHOD OF HALOGEN  
COMPOUND

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month, extending the time for further responding to the Office Action of September 22, 2005 and the Advisory Action of January 13, 2006, from December 22, 2005 to January 23, 2006 (January 22, 2006 being a Sunday).

A check for the statutory fee of \$120.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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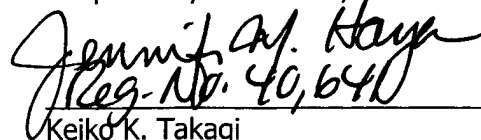
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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Respectfully submitted,

  
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Date: January 23, 2006